



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Seutter *et al.*

FILED: June 12, 2001

SERIAL NO.: 09/880,465

FOR: Low Resistivity Tungsten from  
High-Pressure Chemical Vapor  
Deposition Using Metal-Organic  
Precursors

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ART UNIT:

CONFIRMATION NO:  
5220

EXAMINER:

DOCKET:  
005643

The Honorable Commissioner of Patents  
Box DD  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR 1.97(c)(1)

RECEIVED  
DEC 27 2002  
TC 1700

Dear Sir:

Enclosed herewith for filing under 37 C.F.R. 1.97(c)(1) in the above-referenced matter is a form PTO-1449 together with copies of the references listed therein. Applicants state that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. Applicants believe no fees are due, however, should this be in error, please debit any fees due from Deposit Account No. 07-1185 on which the undersigned is allowed to draw.

Respectfully submitted,

Date: Dec 17, 2002  
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CERTIFICATE OF MAILING UNDER 37 CFR 1.8

RECEIVED  
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Dear Sir:

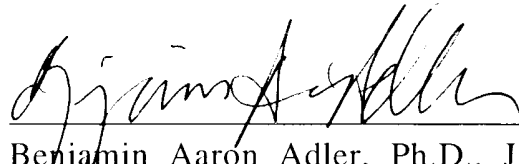
I hereby certify under 37 CFR 1.8 that the following correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to The Honorable Commissioner of Patents, Box DD, Washington DC 20231.

- 1) Information Disclosure Statement;
- 2) Form PTO-1449;
- 3) Three (3) references; and
- 4) Return postcard.

Please return the enclosed postcard acknowledging receipt of this correspondence.

Respectfully submitted,

Date: Dec 17, 2002  
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